

MiniLab S60A

- **Automated Sputter deposition system**
- **Front loading box chamber**
- **Ideal R&D / pilot line production tool**



- **Turbo molecular / rotary vane pumping combination as standard**
- **PLC controlled events**
- **Simple pump/vent operation takes care of vacuum levels**
- **3" Magnetron flexihead as standard DC / RF compatible**
- **Windows process control software system for automated layers**
- **3 gas inlet system. Closed loop baratron/throttle valve PID**
- **Variable speed sample rotation stage with quick release boss**
- **Water cooled quartz crystal sensor**
- **Modular design allows upgrade path (to 4 x 3" sources) and flexibility**
- **Requires minimal services (operates off 20A single phase supply)**
- **LOW COST OF OWNERSHIP**